

Substitute Form PTO-1449 (Modified) <b>APR 21 2003</b> PATENT (87, GPO, 1.98(b))	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. <b>09712-124001</b>	Application No. <b>09/879,428</b>
	<b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)		
	Applicant <b>Henry A. Hill</b>		Filing Date <b>June 12, 2001</b>
		Group Art Unit	

**U.S. Patent Documents**

Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

**Foreign Patent Documents or Published Foreign Patent Applications**

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

**Other Documents (include Author, Title, Date, and Place of Publication)**

Examiner Initial	Desig. ID	Document
	AQ	Isshiki et al., United States Patent Application Publication US 2002/0048026 A1, Published April 25, 2002, entitled "Laser Interferometer Displacement Measuring System, Exposure Apparatus, and Electron Beam Lithography Apparatus,"
	AR	
	AS	
	AT	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	